

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Steven M. Zuniga, et al. Art Unit : 1763
Serial No. : 09/848,830 Examiner : S. MacArthur
Filed : May 3, 2001
Title : A CARRIER HEAD WITH A MULTILAYER RETAINING RING FOR
CHEMICAL MECHANICAL POLISHING

Commissioner for Patents
Washington, D.C. 20231

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RESPONSE

In response to the action mailed May 9, 2002, please amend the application as follows:

In the specification:

Please amend the paragraph beginning at page 1, line 2, as follows:

A¹⁰ This application is a continuation application of and claims priority to U.S. Patent
Application Serial No. 09/090,679, filed June 3, 1998, issued as U.S. Patent No. 6,251,215.

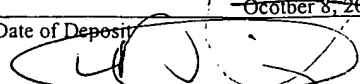
In the claims:

Please amend claim 1, 3-5 and 13 as follows:

1. (Amended) A carrier head for a chemical mechanical polishing apparatus,
comprising:
a rigid base;
A₁ a substrate mounting surface that is vertically movable relative to the base; and
a retaining ring to maintain a substrate beneath the mounting surface during polishing, the
retaining ring including
a substantially annular lower portion having a bottom surface for contacting a
polishing pad during polishing, wherein the lower portion is made of a plastic, and

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

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11/8/02